Series Number:

5000

Type: Multiple Vessel

Stand:

Bench Top

Vessel Mounting:

Moveable

Vessel Sizes, mL: **45 and 75**

Standard Pressure MAWP Rating, psi (bar): **3000 (200)**

Standard Maximum Operating Temp., °C: 225 w/ FKM 0-ring 300 w/ FFKM 0-ring 300 w/ PTFE Flat Gasket

5000 Multiple Reactor System (MRS)

The Parr Series 5000 Multiple Reactor System

has been designed to provide an integrated system for running multiple reactions simultaneously and applying the principles of high throughput experimentation to reactions conducted at elevated temperatures and pressures.

The principal features of the 5000 System include:

- Six reactors with internal stirring.
- Operating pressures to 3000 psi.
- Operating temperatures to 300 °C.
- Individual temperature control.
- Continuous individual pressure monitoring.
- Computer control and data logging.
- Manifold system for rapid turn around and to allow two different input gases.
- Volumes and reactor geometry designed for three phase reactions.
- Flexible Control Software.

Stirred Batch Reaction Vessel

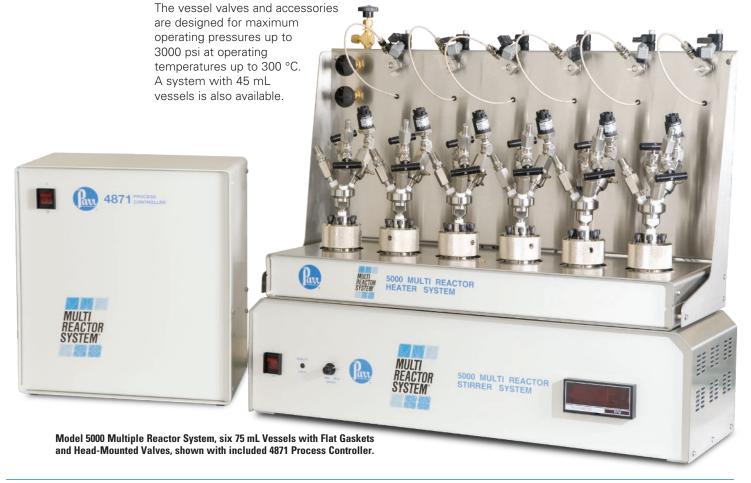
This multiple reaction system has been designed around a vessel with 75 mL total volume. This will accommodate between 15 mL and 40 mL of liquid reactants which is close to the minimum volume appropriate for heterogeneous catalytic reactions.

Stirring System

All six vessels are stirred with a single magnetic stirrer system specifically designed and built for this application. The magnetic drives and fields are focused on the stirrer bars within each vessel. High strength compact magnets are used to provide coupling forces which will operate through the heaters and vessels. The stirring speed of the stirrer bar is variable from 0-1200 rpm. All vessels will have the same stirring speed during a single run of the apparatus. This arrangement ensures that the difference in reaction rates between vessels run in parallel are due to set conditions other than variations in stirrer speed.

Heaters

The external heaters surround the vessel walls for rapid and uniform heating and temperature control. Each vessel is individually temperature controlled. The 250-watt heater used on each vessel produces heating rates up to 15 °C per minute. An optional reactor cooling support rack is available for air-cooling.



Shaded bar indicates specifications th	at change with	iii series.		
Model Number		50	000	
Approximate Sizes, mL	4	15		75
No. of Reaction Vessels			6	
Maximum Pressure (MAWP)		3000 psi	(200 bar)	
Maximum Temperature				
with FKM 0-ring		22	5°C	
with FFKM 0-ring		30	0°C	
with PTFE Flat Gasket		30	0°C	
Closure				
with 0-ring		Scre	w Cap	
with Flat Gasket	9	Screw Cap (6 Co	ompression Bol	ts)
Material of Construction		T3	16SS	
Process Controller		Mod	el 4871	
Analog Inputs		6 Temp	perature	
		6 Pre	essure	
		1 Moto	or Speed	
Analog Outputs		1 Stirrer Spe	eed (Optional)	
Digital Outputs	6 PID Temperature Control			
Temperature Measurement	6 Thermowells			
Heater Style	6 Band Heaters, Aluminum Block			
Heater Power, Watts	250W Per Station, 1500W Total			
External Thermocouple	Optional			
Stirrer Motor Type	Manual or Computer Controlled			
Stirrer Style	PTFE-	or Glass-Coate	d Magnetic Sti	rrer Bar
Electrical Supply				
Volts, AC		115	/ 230	
Maximum Load, amps, 115 / 230		15	/ 7.5	
Vessel Dimensions				
Inside Diameter, inches	1.	18	1	.50
Inside Depth, inches		2.69 Flat Gas	ket, 2.50 O-ring	
Weight of Vessel, pounds		3 ounted Valves)	(w/ Head-Mo	6 ounted Valves)
Dimensions	Width, in.	Depth, in.	Height, in.	Weight, Ibs
Heater	25.75	9.25	2.875	31
Stirrer	28	9.5	7.625	12
4871 Controller	13	11	15	14
Manifold, Remote	26.5	9.0	15	36
Manifold, Head Mount	26.5	9.0	15	18
Spare Parts Kit 5009M				

Operating Modes

The Series 5000 Multiple Reaction System provides an apparatus for running up to six reactions in parallel to build a database for comparing and optimizing operating conditions. The user can design experiments to:

- Run all reactions at the same temperature and pressure while varying catalyst loading or reactant concentrations to optimize these parameters.
- Run all reactors with identical loads varying pressures at a common temperature to study the effect of pressure on reaction rates.
- Run individual reactors with individual loading and temperature and pressure to screen multiple options for activity.

A comparison of the plots of pressure drop versus time within the reactors running under parallel conditions will usually be the most useful means of measuring reaction rates and comparing operating conditions. The internal thermocouple also provides a means of detecting temperature changes due to exothermic reactions.

Reactor Options

As Parr customers have come to expect with our line of laboratory pressure reactor equipment, these reactors are offered with a number of options which permit the user to configure the system to their reactions and intended operating conditions. These options include:

O-ring or Flat Gasket Seals. Vessels with O-ring seals are closed by simply tightening the screw cap down hand tight. The maximum operating temperature will depend upon the O-ring material. When equipped with FKM (Viton®) O-rings operating temperatures up to 225 °C are permitted. By substituting FFKM (Kalrez®) O-rings this limit can be raised to 300 °C. Careful consideration of chemical compatibility must also be given when selecting O-ring materials. PTFE gaskets can be used to temperatures up to 300 °C and offer virtually universal chemical compatibility. Six compression bolts are used to develop the sealing forces on the PTFE gaskets in this design.

5000

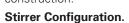
5000 Multiple Reactor System (MRS)

Head Configuration. Each reaction vessel is equipped with an inlet valve, exhaust valve, safety rupture disc, and pressure transducer in addition to an internal thermocouple. Vessels can be modified to include a dip tube for liquid sampling or a cold finger for cooling. The user can choose to have the valves, transducer and rupture disc mounted on a multi-port adapter connected directly to the vessel head, or remotely mounted on the back panel.

- Head Mounted. The head mounted design makes it possible to remove the pressurized vessels from the heater/stirrer assembly or to prefill the vessels in a remote location. PEEK flexible tubing with a quick slip connector is provided for each vessel for inlet of gas. Tubing is easily removed after gas fill.
- Panel Mounted. The remote panel mounted arrangement connects all the pressure inlets/ outlets to each vessel with a single PTFE lined stainless tubing. Alternate stainless steel tubing is offered if required. In the panel mount valve configuration the gas inlet tubing generally remains attached to the vessels during operation.

Materials of Construction. Type 316 Stainless Steel is the standard material of construction for

both the vessel with its wetted parts and the valve and head fittings exposed to vapors. For investigators working with systems containing strong mineral acids or other more corrosive systems these vessels can be made of most of the Parr standard materials of construction.



Stirring is accomplished by use of either PTFE coated or glass coated magnetic stirrer bars.

Thermocouple Configuration.

Thermocouples are mounted inside the vessel for the best temperature monitoring and control. The thermocouples

MRS with individually controlled Gas Burettes.

are protected by stainless steel sheaths which are inserted into a protective thermowell. These thermowells make it easy to install and remove thermocouples from the vessels, and also provide additional chemical and mechanical protection for the thermocouple.

We also offer an external thermocouple option with the thermocouples positioned in contact with each cylinder wall.

Gas Manifold. The brass gas inlet manifold is designed to handle both a purge gas, usually nitrogen, and a reactant gas, usually hydrogen. This can be set up to automatically fill each vessel to the same initial pressure or to manually fill each vessel to a unique operating pressure. This gas manifold can also be supplied in T316SS to meet more corrosive requirements.

Gas burettes. For applications where gas consumption measurement is important, optional high pressure gas burettes can be provided (see photo on this page). These burettes allow monitoring/calculation of the number of moles of gas consumed during a reaction. A complete description and list of available volumes and delivery pressure ranges can be found on page 126 of this catalog (or at https://www.parrinst.com/hpb.

4871 Process Controller

The Series 5000 Multiple Reaction System is controlled by a dedicated Parr 4871 Process Controller. A detailed description of this controller is found in Chapter 6 of this catalog, page 109.

For this application the controller is set up to provide:

- Temperature monitoring and PID control of each individual reactor
- Pressure monitoring of each individual reactor
- Data logging of temperature and pressure in each reactor
- Control and logging of the common stirring speed of the reactors.

The controller provides Ramp & Soak programming for individual reaction vessels, digital inputs and outputs for interlocks, alarms or other safety features, and additional analog and digital inputs and outputs to control flow meters or other accessories which might be added at some future date. The user's control station is a PC running any current Windows operating system. A simplified graphical user interface has been designed for the control and monitoring of the Series 5000 Multiple Reaction System. The PC is used strictly as the user interface and data logging module. All control actions are generated in the 4871 Process Controller (not the PC).



Series 5000 Ordering Guide

The Order No. for the Base System is: 5000(45)-T-SS-115-P-MV-2000-MB-CC

A composite identification number to be used when ordering a 5000 Series Reactor can be developed by combining individual symbols from the separate sections below. For more information on how to use this ordering guide, please see page 27.

A Base Mo	odel
Model No.	Size
5000	45 or 75 mL

B Gasket /	B Gasket / Maximum Temperature	
-0V	FKM O-ring, 225 °C	
-0K	FFKM O-ring, 300 °C	
-T	PTFE Flat Gasket, 300 °C	

C Materia	Is of Construction
-SS	T316 Stainless Steel
-M0	Alloy 400
-IN	Alloy 600
-HB	Alloy B-2 / B-3
-HC	Alloy C-276
-CS	Alloy 20
-TI2	Titanium Grade 2
-TI4	Titanium Grade 4
-ZR702	Zirconium Grade 702
-ZR705	Zirconium Grade 705

See page 10 or 24 for complete list of available alloys.

D Electrical Supply	
-115	115 VAC
-230	230 VAC

E Thermocouple	
-No Symbol	Type J (Standard)
-K	Type K

F Valve Mounting	
-H	Head Mount w/ PEEK Tubing
-P	Remote Panel Mount w/ PTFE Lined SS Hoses

G Inlet Valve		
	-AC	Automatic Check Valve
	-MV	Manual Valve

H Transducer Range		
	-1000	0-1000 psi
	-2000	0-2000 psi
	-3000	0-3000 psi

Stirrer Type	
-MB	Magnetic Bar Stirrer, PTFE
-GB	Magnetic Bar Stirrer, Glass

J Stirring Control	
-M	Manual
-CC	Computer Controlled
-RPM	Digital RPM Display

K Certifications	
-No Symbol	No Certification
-ASME	ASME Certification
-PED	PED Certification
-P	Parr Certification

(L) Options	
-SV*	Dip Tube with Sampling Valve
-CF*	Cold Finger
-MPG	Manifold Pressure Gage
-FMH	Flexible SS Hoses
-E-TC	External Thermocouple
-R-TC	Redundant Thermocouple
-RCS	Reactor Cooling Support
-2280	Gas Burettes (see page 126)

* Dip Tubes & Cold Fingers cannot be installed at the same time.

M Spare Parts	
-5009M	Spare Parts Kit for 5000 Series
-5050	Replacement Vessel, T316SS, 75 mL, including head, cylinder, screw cap and thermowell
-5051	Replacement Vessel, T316SS, 45 mL, including head, cylinder, screw cap and thermowell

Other Available Options
Glass Liner
PTFE Liner

Parr also designs and builds a wide range of multiple reactor systems with overhead magnetic drive stirrers. Many of these multiple reactor systems have been based upon our Series 4590 Micro Reactors, Series 4560 Mini Reactors, and our Series 5500 High Pressure Compact Reactors. We have also supplied multiple reactor systems based on our largest 4555 Stirred Reactor Series. Please see page 74 of this catalog for examples. Contact our Customer Service Department for details and proposals for custom systems.